Prospects of X/X_0 measurements at the CERN SPS test beam
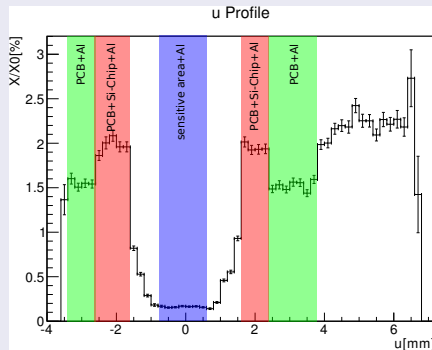
Ariane Frey, Benjamin Schwenker and Ulf Stolzenberg*

University of Göttingen, II. Physikalisches Institut

October 2nd 2014, 17th DEPFET Workshop in Pisa

VolkswagenStiftung

X/X_0 Measurement at CERN

- X/X_0 measurements with errors below 10 % at DESY, but does it also work at CERN SPS test beams?
- Main problem at CERN: small MSC distributions due to high beam energy
- But: Better angular resolution than at DESY
- What setup and beam energy should be used? And what angular resolution can be achieved in the best case?

Multiple scattering

Highland Formula(only small scattering angles)

$$\sigma_{\mathrm{HL}} = \frac{0.0136 \cdot q[e]}{\beta \cdot p\,[\mathrm{GeV}]} \cdot \sqrt{\frac{X}{X_0}} \left(1 + 0.0038 \ln\left(\frac{X}{X_0}\right)\right) \mathrm{rad}$$

V. L. Highland, *Some practical remarks on multiple scattering*, Nuclear Instruments and Methods,1975

CERN SPS, 120 GeV pions
- $150\mu m$ Si: σ_{HL}=3.4 μrad
- 100mm air: σ_{HL}=1.4 μrad
- 5mm alu: σ_{HL}=23.9 μrad

DESY, 4 GeV electrons
- $150\mu m$ Si: σ_{HL}=102.7 μrad
- 100mm air: σ_{HL}=42.8 μrad
- 5mm alu: σ_{HL}=717 μrad

Multiple scattering

Highland Formula(only small scattering angles)

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Consequences for MSC studies at CERN

- The MSC distribution on the central plane is very narrow
- Angle reconstruction error ($\widehat{=}$ telescope angular resolution) must be small and known extremely precisely
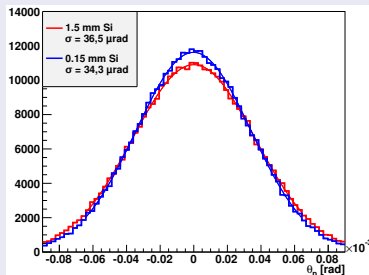
MC Simu Telescope setup
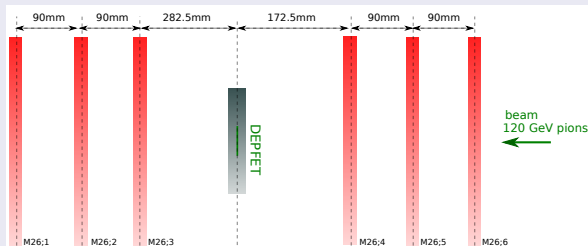
Angular resolution of this setup

- Setup of CERN Test Beam in October 2012
- $\sigma_{\mathrm{reco}} = 33.7$ μrad for 120 GeV pions (without calibration)
- Typical angular resolution at DESY: 190 μrad

Example of reconstructed angle distributions

1.5 mm Si and 0.15 mm Si MSC angle distributions

- Distributions insensitive to (even large) X/X_0 changes
- $\sigma_{\mathrm{total}} = \sqrt{\left(\sigma_{\mathrm{reco}}\right)^2 + \left(\sigma_{\mathrm{HL}}\right)^2}$
- Problem: Both distributions completely dominated by angular resolution

Solution

- Setup must be optimized to reduce influence of angular resolution
- Alternatively: Use thicker target materials or reduce beam energy

MSC angle distributions of Test Beam Run 73407

- October 2012 CERN TB setup $\rightarrow \approx 90$ mm gaps between sensors
- Angular resolution: $\sigma_{\text{reco}}^{\text{exp.}} = 33.7\mu$rad

Comparison between MC Simulation and real data

Second projected angle
Only Sensitive area

MC Simu
Real data

θ_z [mrad]
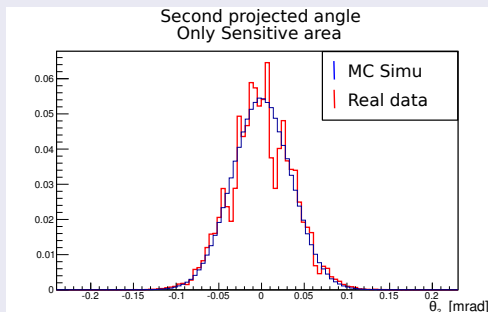
- basic shapes of mc and data distributions are compatible
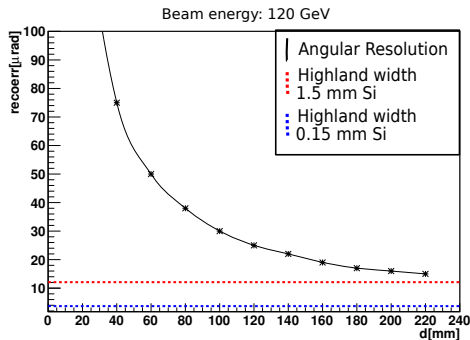- But: Strange fluctuations in data distribution
- caused by misalignment?

Optimal Setup for CERN SPS Test Beams
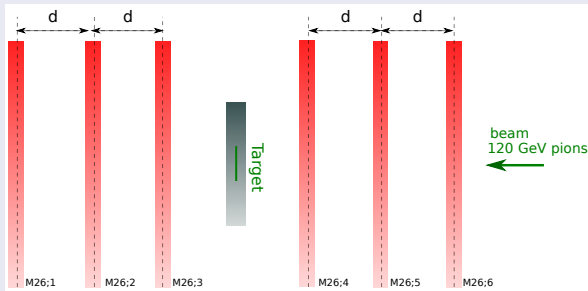
Telescope Setup

- Vary distance *d* between the M26 sensors
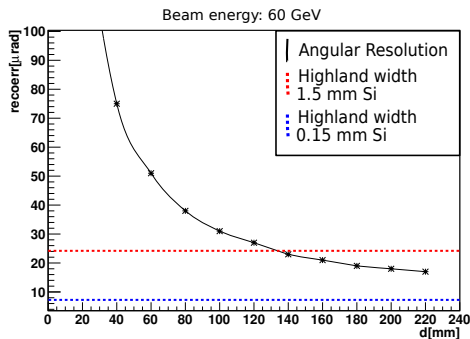- max distance between Mimosas at CERN: ≈ 15 cm

Optimal Setup for CERN SPS Test Beams

Optimal Setup at CERN TB

- Choose gaps as large as possible to optimize the telescope resolution

- Maximal realistic gap size: 15 cm $\rightarrow \sigma_{\mathrm{reco}} = 20.6 \ \mu$rad

Optimal Setup for CERN SPS Test Beams


Optimal Setup at CERN TB

- If possible beam energy should be reduced $\rightarrow$ larger σ_{HL} values
- $\sigma_{\mathrm{reco}} = 22.2$ μrad at 60 GeV and d=15cm

Calibration of the angular resolution

Calibration factor λ, $\sigma_{\mathrm{reco}} = \lambda \cdot \sigma_{\mathrm{reco}}^{\mathrm{exp.}}$

λ contains the influence of all systematical errors on the telescope angular resolution, for example errors due to neglecting MSC tails in the tracking
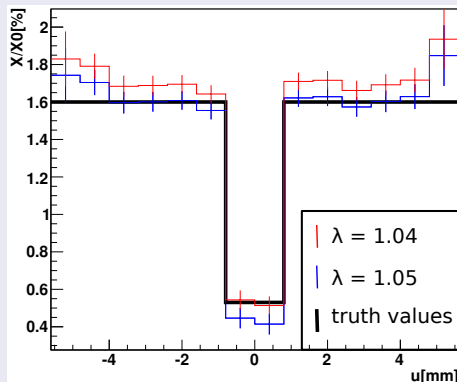
Radiation length u Profile for optimal setup (d=15cm, p=120GeV), simulation
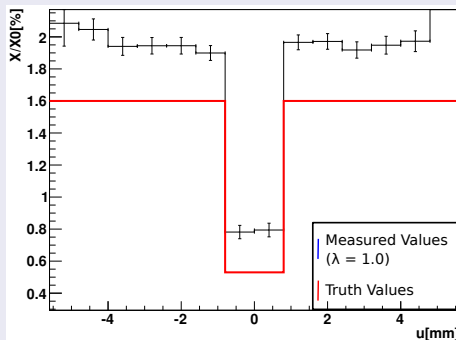
- $\lambda = 1.0$
  $\rightarrow \sigma_{\mathrm{reco}} = 20.6\mu\mathrm{rad}$
- 0.5 mm of Silicon between u=-0.8mm and u=0.8mm and 1.5 mm Si on the outside
- Radiation length is overestimated
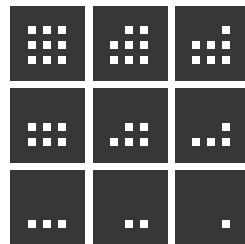
Calibration of the angular resolution II

$\lambda= 1.05$ and $\lambda=1.04$ profile comparison

- statistical error of $\Delta X/X_0 \approx 0.05\%$
- Changing λ from 1.04 to 1.05 causes a 0.1 % X/X_0 change in this setup
- λ must be known up to a few permil to ensure a precise measurement
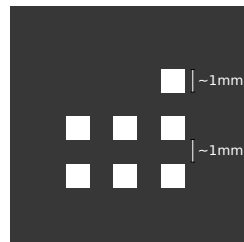
Alu target for calibration

- Target consisting of 9 aluminum layers with different configurations of a 3×3 hole array in each layer

A very similar target has already been used at DESY for X/X_0 measurements

Alu target for calibration

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- rectangular holes with $\approx$ 1mm side length
- distance between holes also $\approx$ 1mm

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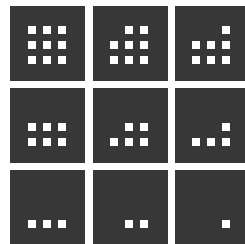
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- Thickness of layers should between 0.5 mm and 1 mm

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Prospects of X/X_0 measurements at the CERN SPS test beam

Alu target for calibration

- Target consisting of 9 aluminum layers with different configurations of a 3×3 hole array in each layer
- rectangular holes with ≈ 1mm side length
- distance between holes also ≈ 1mm
- Thickness of layers should between 0.5 mm and 1 mm
- Position of target doesn't have a large effect on angle reconstruction
  → Attach alu target to inner M26 sensor
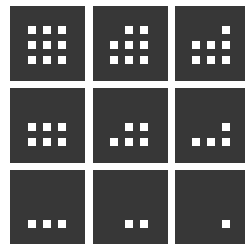
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Conclusion

To optimize the X/X_0 measurement:

- Use large distances between M26 sensors (max distance $\approx$15 cm at CERN)
- Use lowest possible beam energy (if possible $\approx$ 60 GeV)
- Do calibration measurements with an aluminum target including a thickness profile
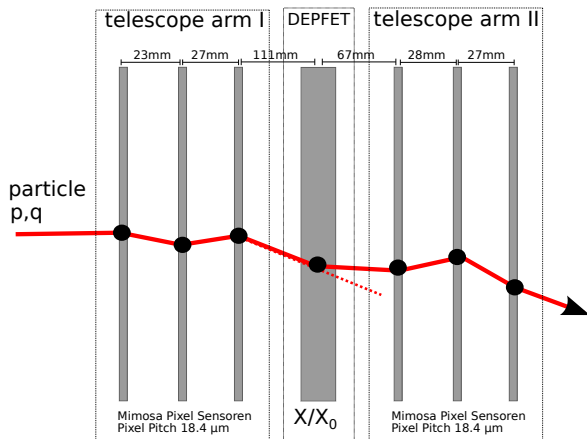
PXD6 Measurement

We plan to do a spatial resolved measurement of a PXD6 module including some of the surrounding ASICs
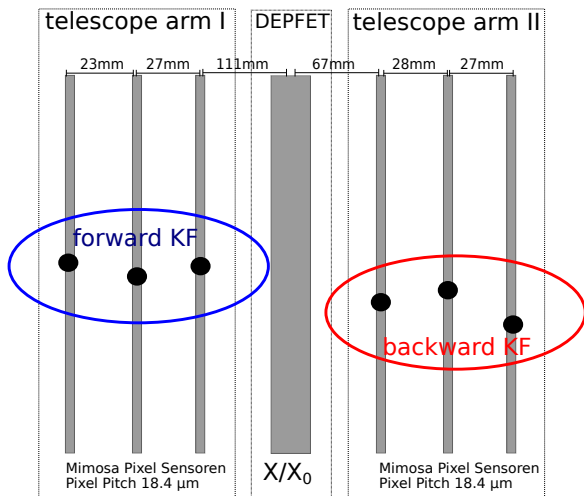
Thank you
for your attention!

Back Up Slides

Reconstruction of MSC angles in a EUDET telescope

- Reconstruct angles on the DEPFET
- Particle crosses sensor $\rightarrow$ hits

Reconstruction of MSC angles in a EUDET telescope

- Reconstruct angles on the DEPFET
- Particle crosses sensor $\rightarrow$ hits
- Forward- backward Kalman Filter (KF) pair on hits
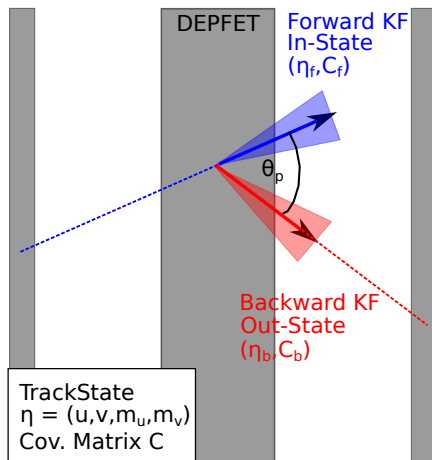- hit on DEPFET not needed $\rightarrow X/X_0$ map
- Take MSC in air gaps into account

Reconstruction of MSC angles in a EUDET telescope

- Reconstruct angles on the DEPFET
- Particle crosses sensor → hits
- Forward- backward Kalman Filter (KF) pair on hits
- hit on DEPFET not needed → X/X_0 map
- Take MSC in air gaps into account
- θ_p calculated from (m_u, m_v)
- Reco error σ_{reco} from error propagation

Forward and Backward KF

Forward KF

- gives In-State
- prediction of track state on sensor i+1 based on tracks state i

$$\eta_{i+1} = F_{i \to i+1} \eta_i$$
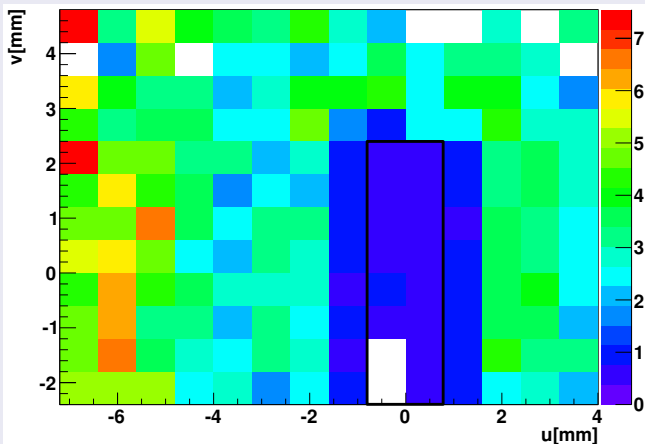$$V_{i+1} = F_{i \to i+1} V_i F_{i \to i+1}^{\mathrm{T}}$$
$$+ Q_{\mathrm{F;i}}$$

Backward KF

- gives Out-State
- prediction of track state on sensor i based on tracks state i+1

$$\eta_i = F_{i+1 \to i} \eta_{i+1}$$
$$V_i = F_{i+1 \to i} V_{i+1} F^{\mathrm{T}}_{i+1 \to i}$$
$$+ Q_{\mathrm{B};i+1}$$

- F: Extrapolation matrix
- Q: MSC effects

DEPFET Hybrid 4 Map

H4 module, p=120 GeV

Results of 4 different configurations

sensor distance 9cm, p=120GeV

- $\sigma_{\mathrm{reco}}^{\mathrm{exp.}} = 33.7\mu\mathrm{rad}$
- $\sigma_{\mathrm{HL}}(0.5\mathrm{mm\,Si}) = 6.6\ \mu\mathrm{rad}$
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- reliable measurement of 1.5 mm of Silicon possible

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